

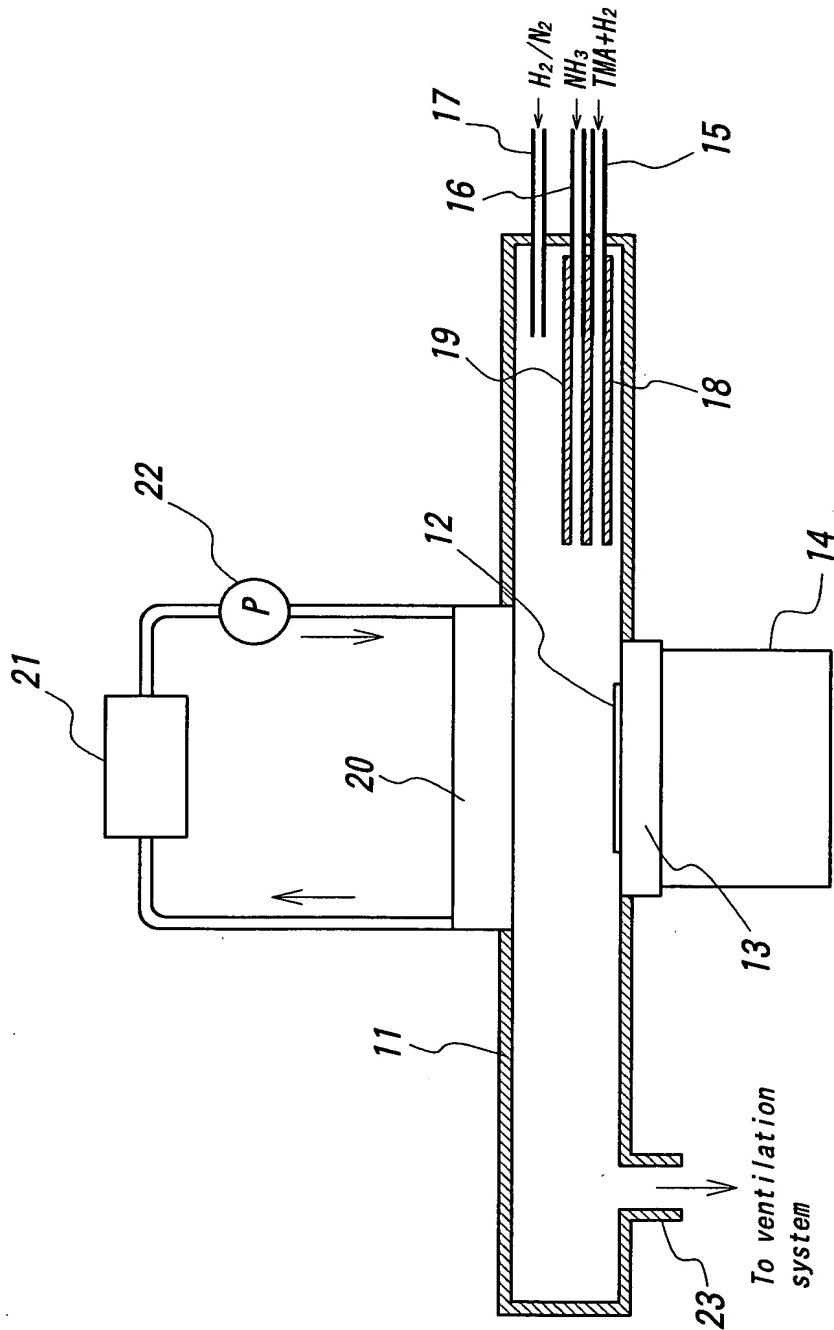
Applicant(s): Tomohiko SHIBATA, Yukinori NAKAMURA and Mitsuhiro TANAKA

Title: A METHOD FOR FABRICATING A III-V NITRIDE FILM AND AN APPARATUS FOR FABRICATING THE SAME

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FIG. 1



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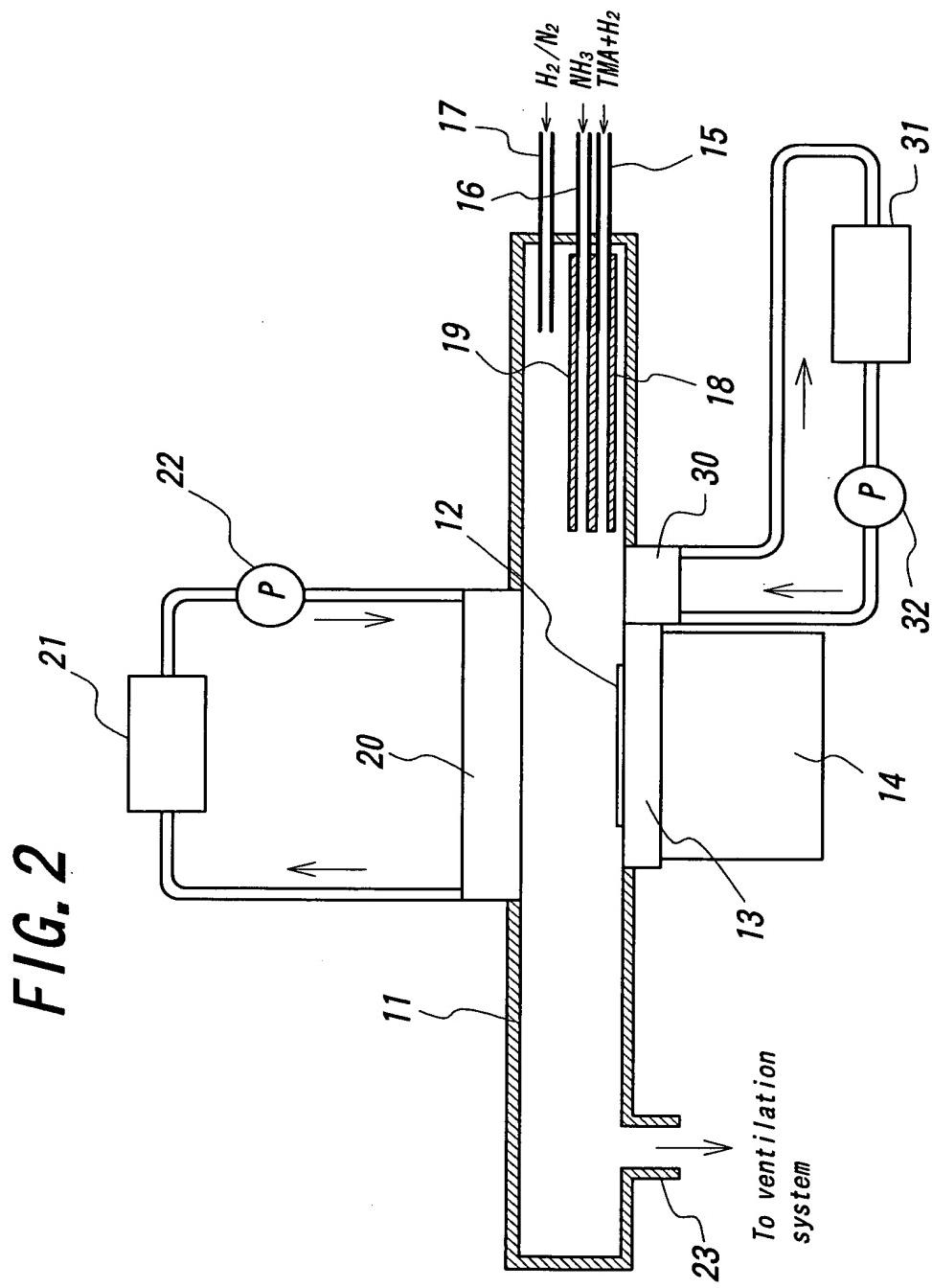


FIG. 3

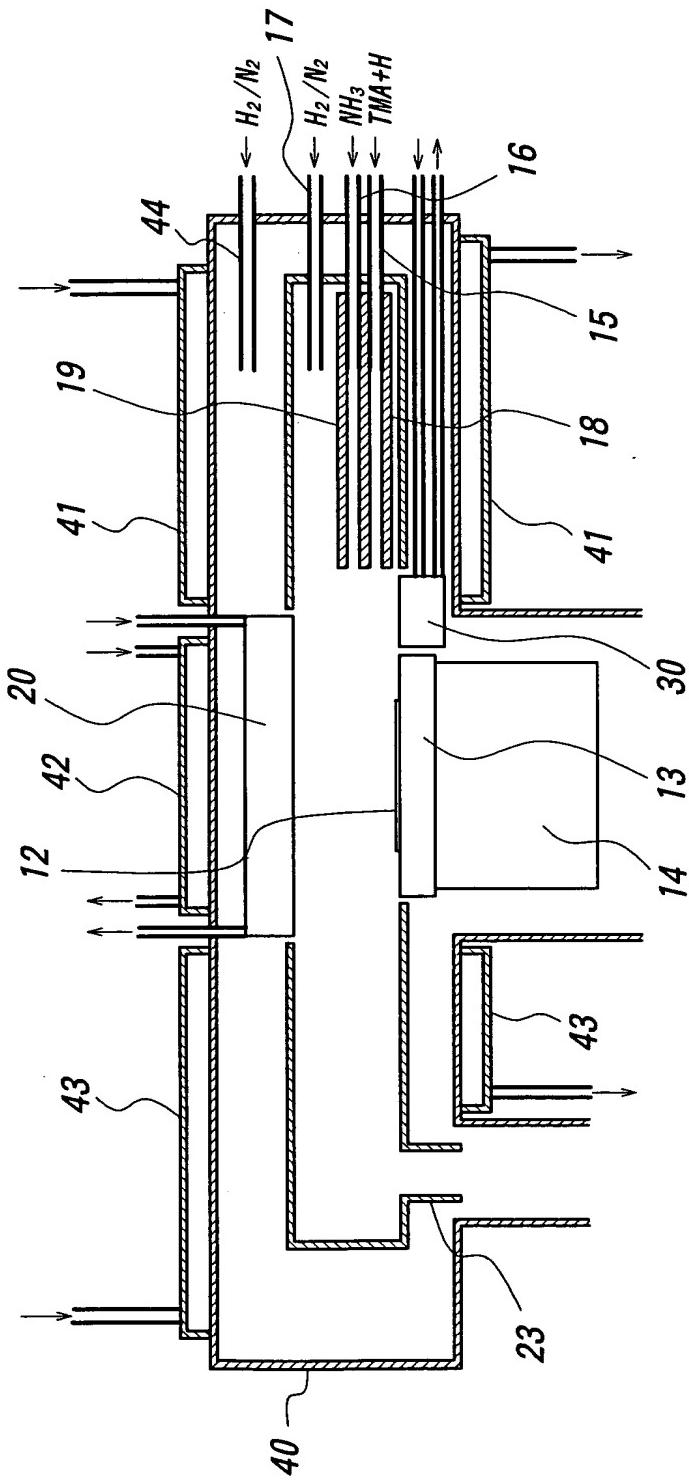
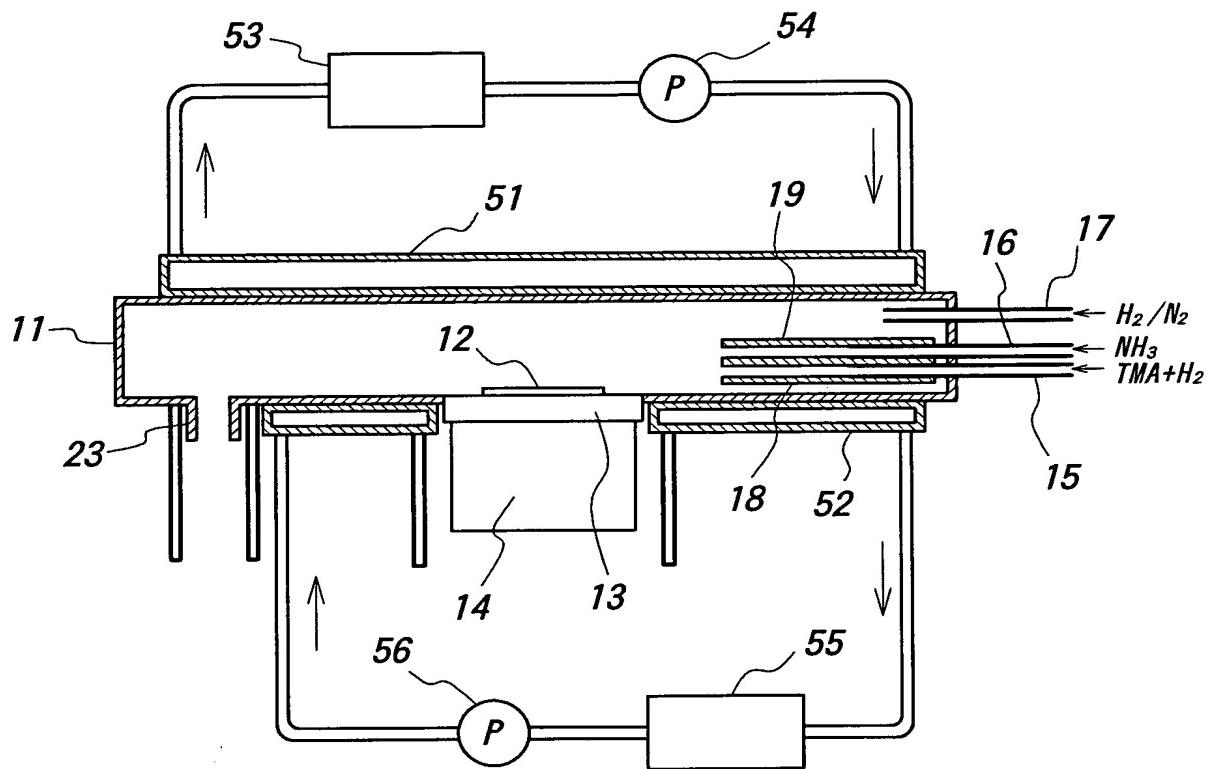


FIG. 4



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FIG. 5

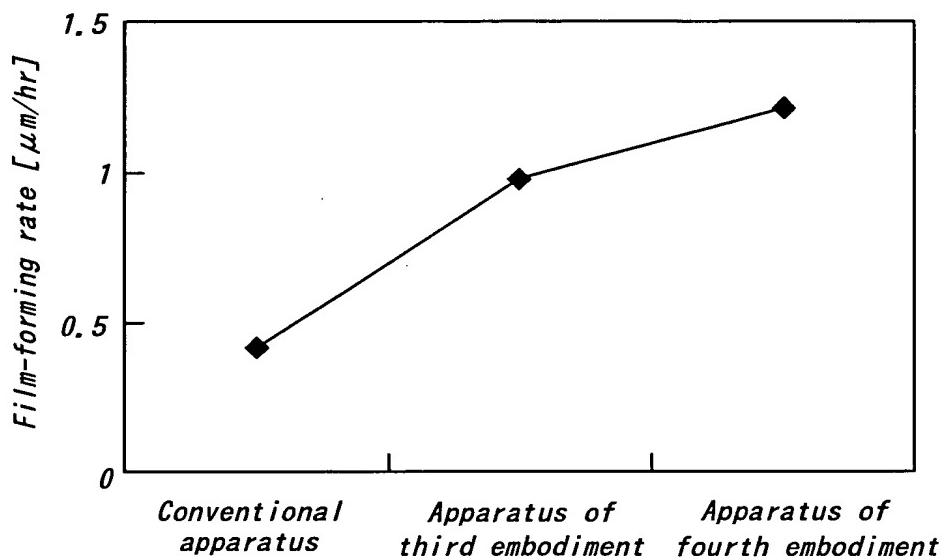


FIG. 6

